

# Ion Sources

Some characteristics of ion sources (especially in high precision work):

- It should have high efficiency in generating ions of the element of interest (or a range of elements).
- All of the ions should have the same energy.
- It should produce an ion beam with low divergence.
- The ions should be the same charge (preferably +1 for positive ions or -1 for negative ions) so we separate by mass and not  $m/q$ .
- The ion beam should be stable.
- The ion beam should have isotopic ratios the same as the sample.

# Thermal Ionization MS

## ■ Advantages

- Extremely Stable
- Generally less prone to isotopic fractionation effects than other sources
- Thermalized ions (narrow energy range)

## ■ Disadvantages

- Complicated sample preparation
- Incomplete isotope (elemental) coverage
  - » Inconsistent positive or negative ionization efficiencies across periodic table

# Inductively Coupled Plasma MS

## ■ Advantages

- High sensitivity
- Nearly complete isotope coverage
- Liquid, solid or gas samples
- Short analysis times
- Less “art”

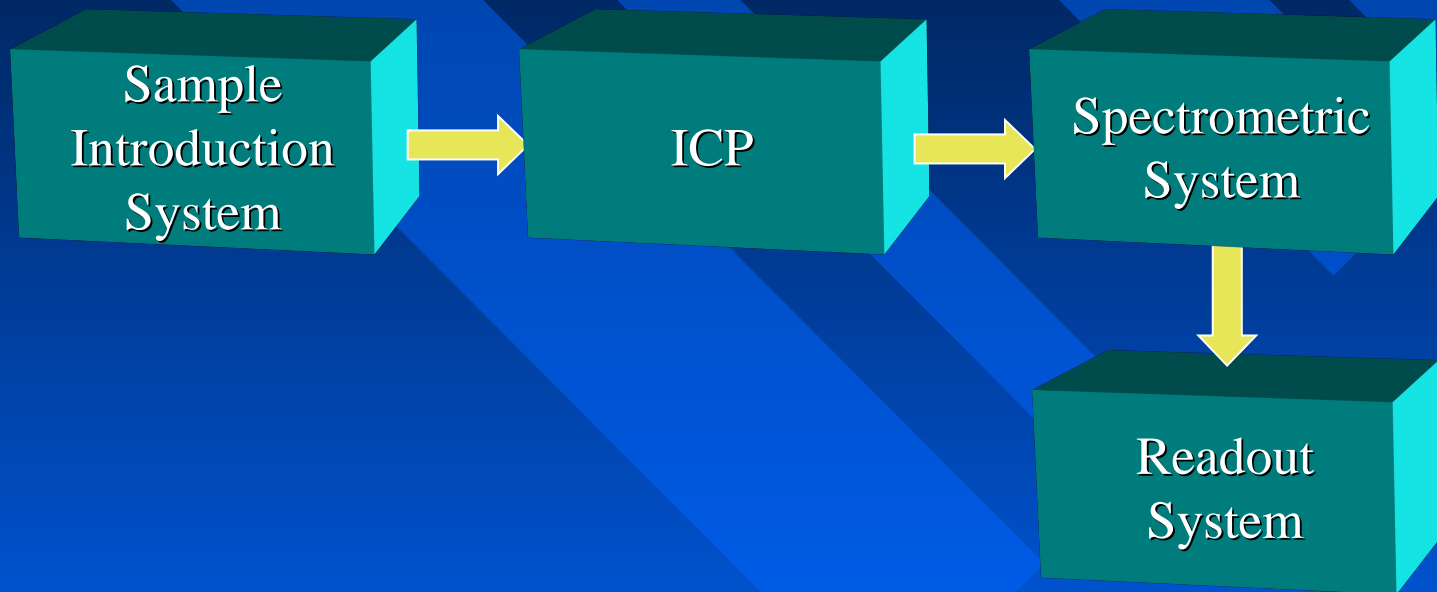
## ■ Disadvantages

- Isobaric interferences
- Relatively noisy
- Wide ion energy spread
- Inefficient
- Spectral complexity

# So what is the ICP?

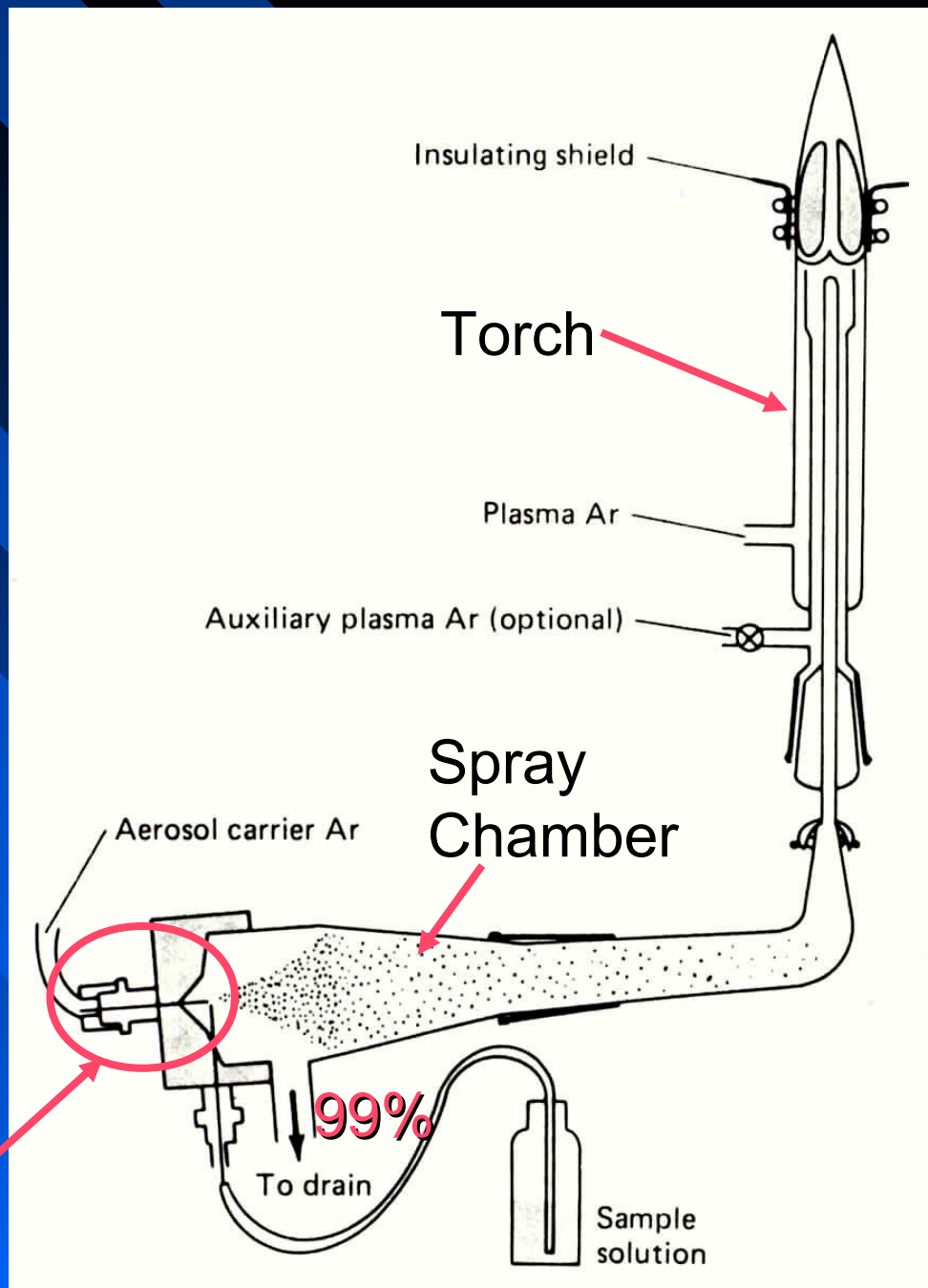
- What equipment does it require?
- How does it operate?
- What are its features?
- How does it work with MS?

# Basic ICP Instrument



# Inductively Coupled Plasma - Atomic Emission Spectrometry (ICP-AES)

Nebulizer



# Types of ICP Nebulizers

- Concentric pneumatic
- Cross-flow pneumatic
- Ultrasonic (high sensitivity)
- High-solids (V-groove, Babington, etc.)
- .....

# Types of ICP Spray Chambers

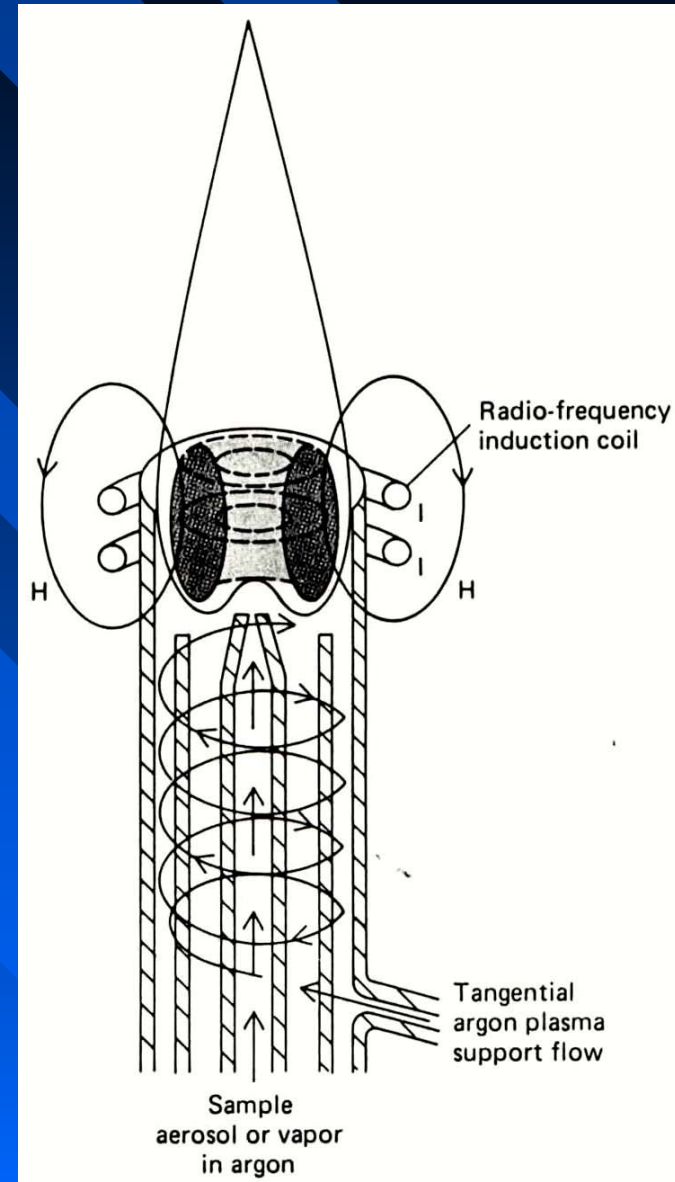
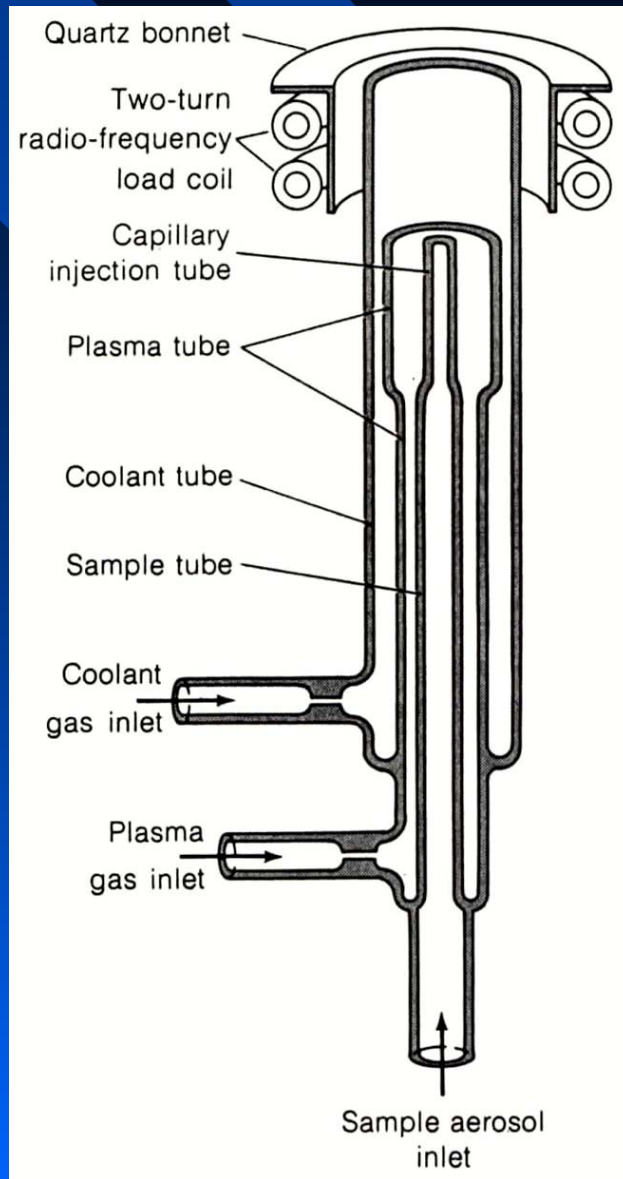
- Scott-type
- High-efficiency
- Cyclonic
- Desolvating
- .....



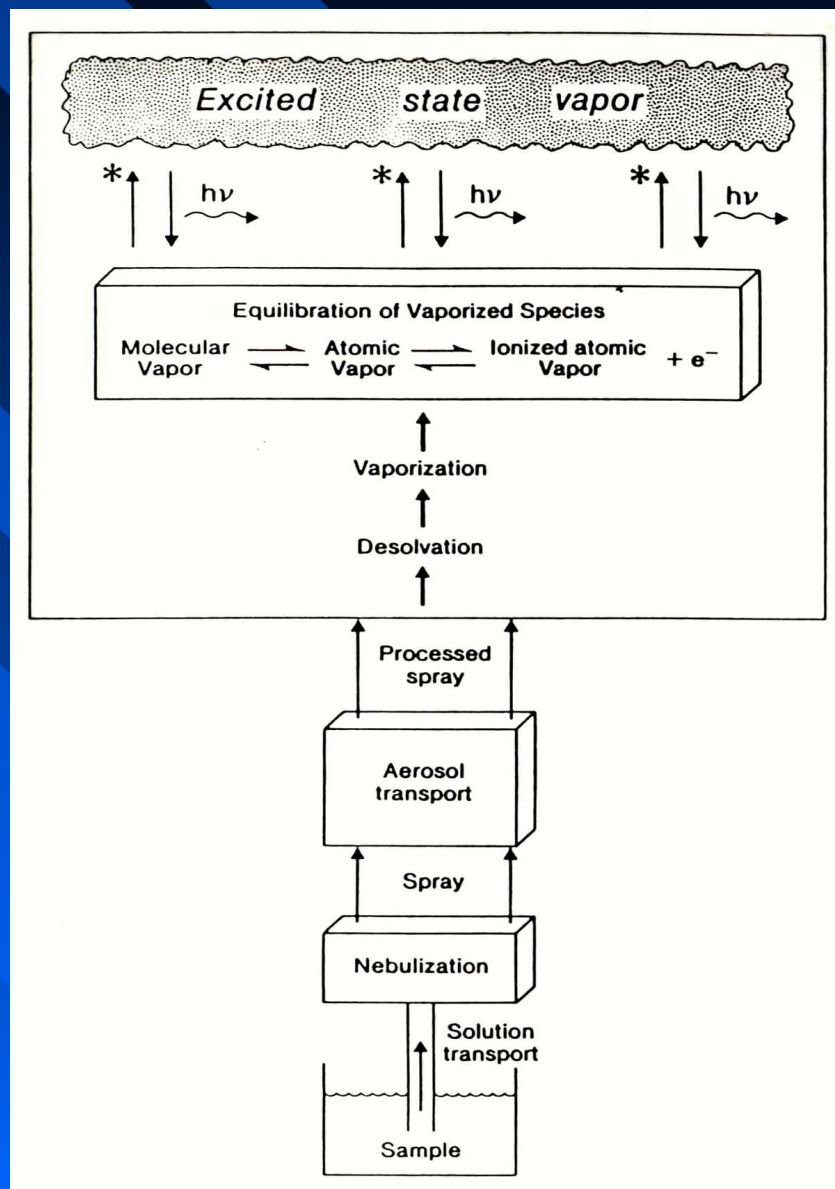
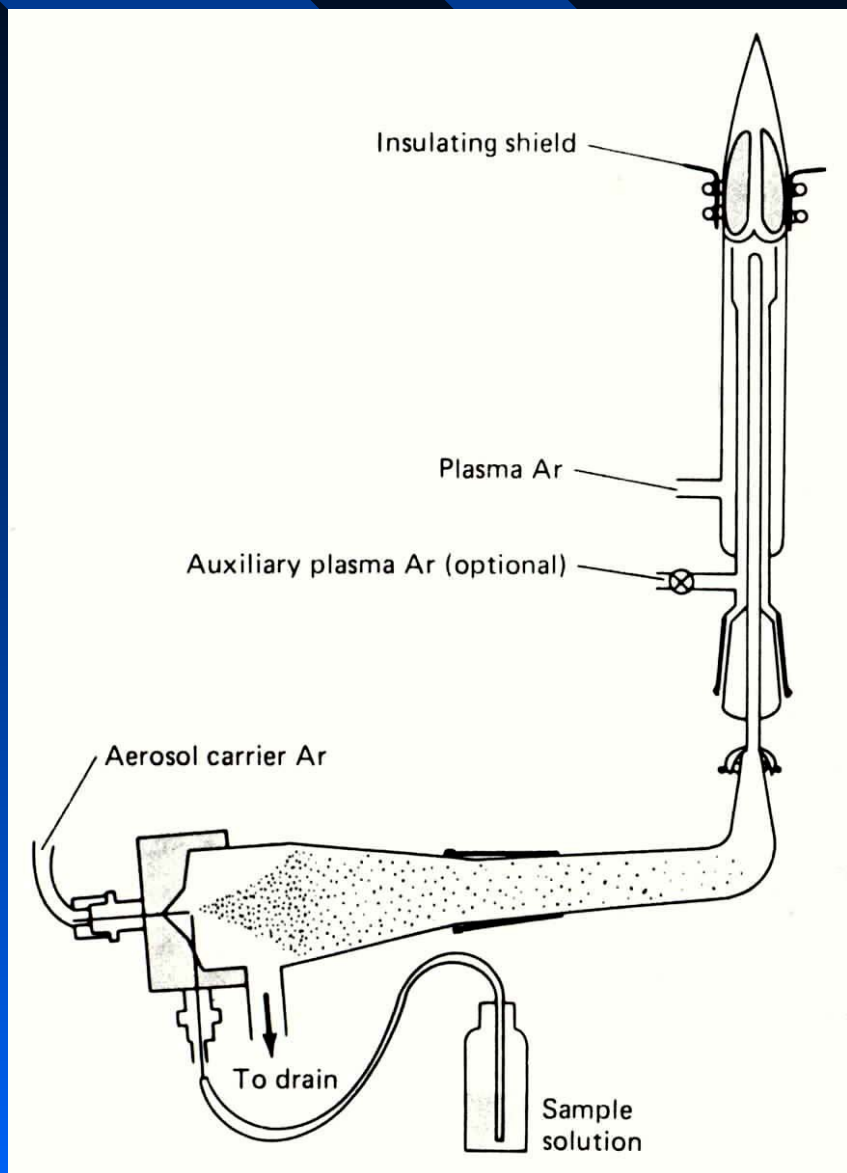
# The Inductively Coupled Plasma

- A plasma is a hot, partially ionized gas.
- The ICP is an argon-based, radio frequency plasma.
- The input rf frequency is either 27 or 40 MHz at powers from 1 to 2 kW.
- The plasma is formed and contained in a three tube quartz torch.
- The temperature in the central analyte channel ranges from about 6000 to 8000° K.
- At these temperatures most elements are largely atomized and ionized

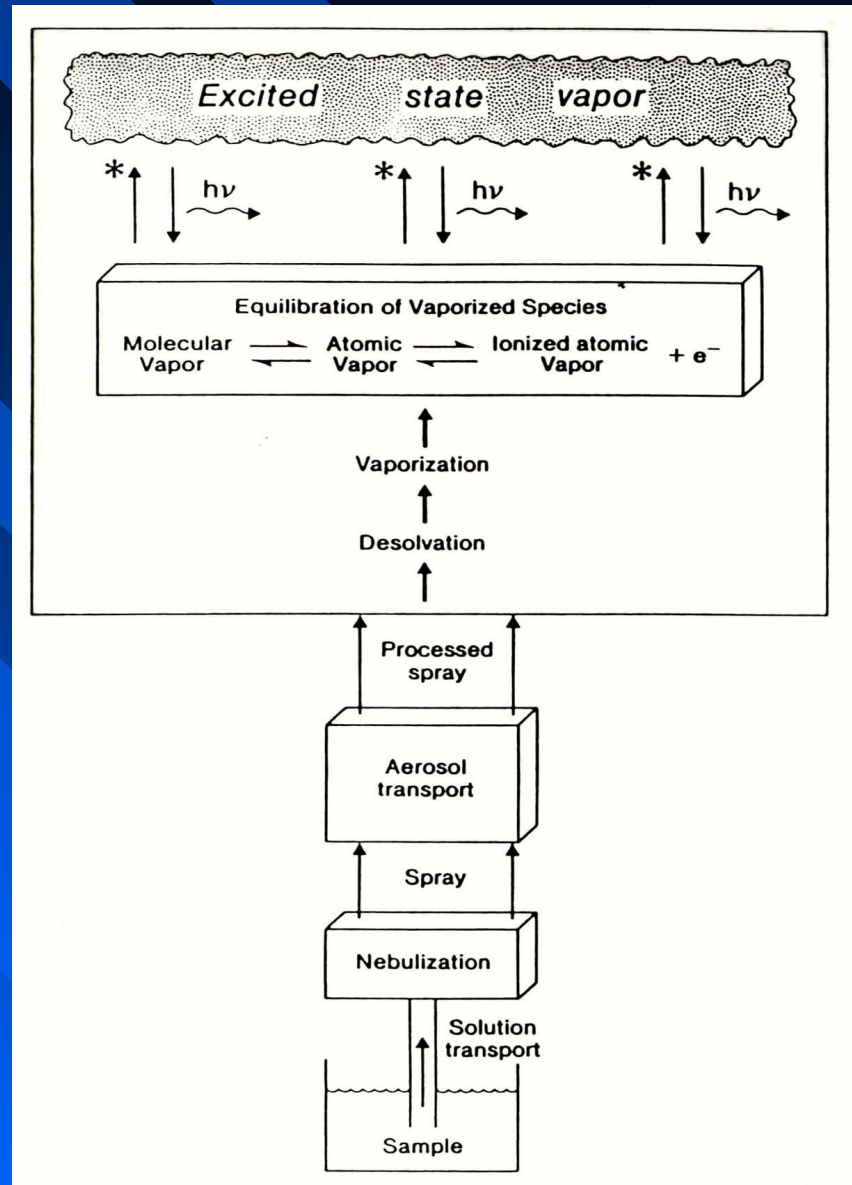
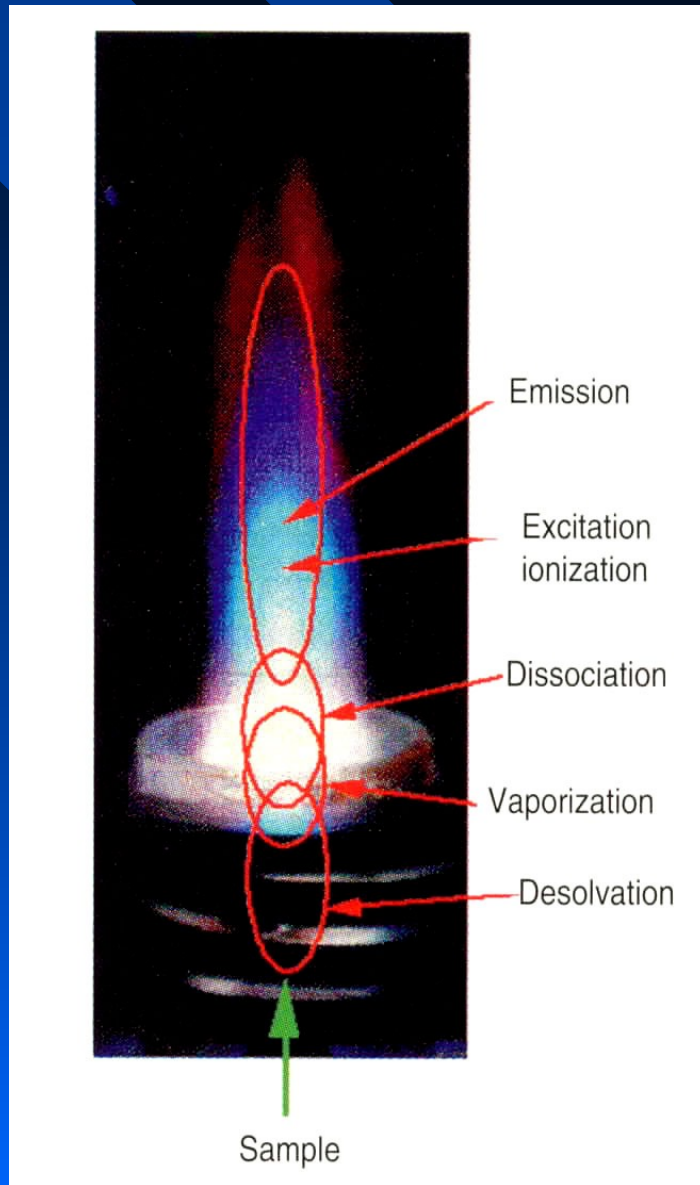
# The ICP Torch and Plasma



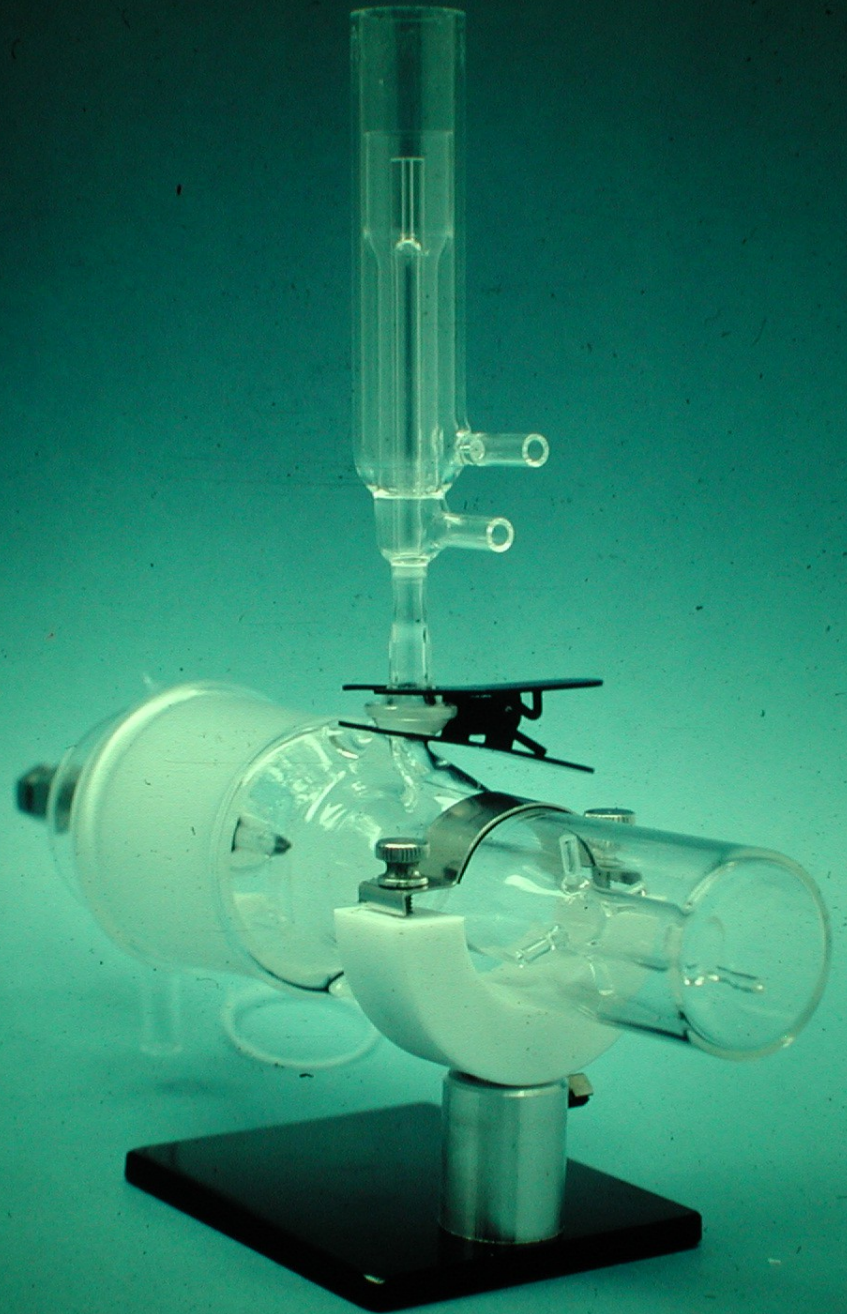
# THE STEPS



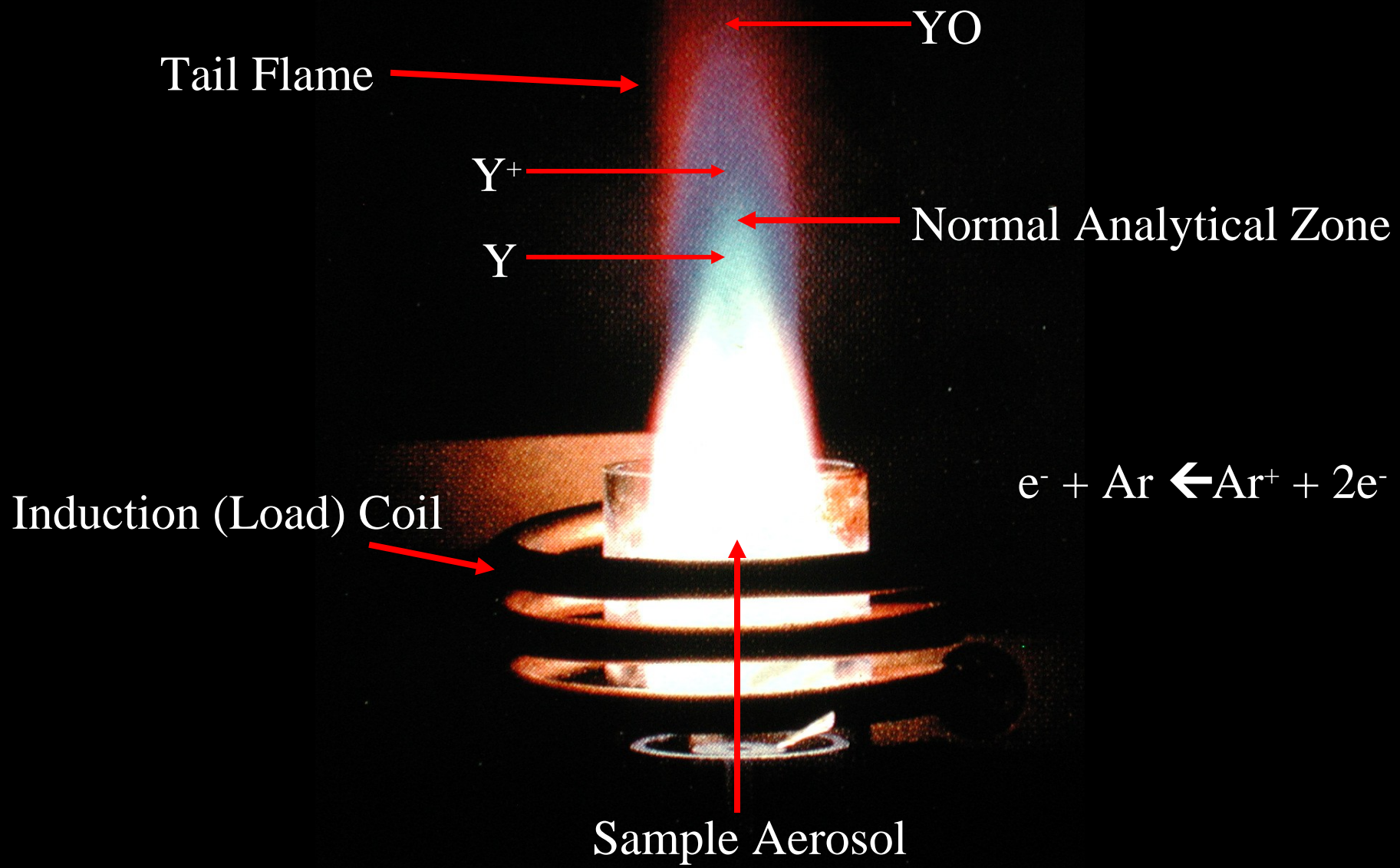
# THE STEPS



ICP torch,  
nebulizer,  
spray  
chamber

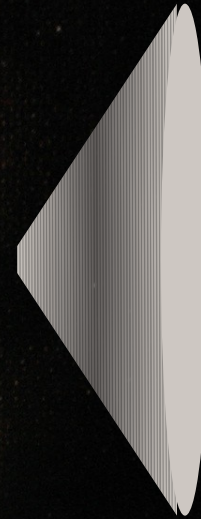
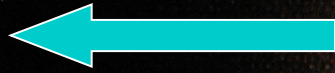


# Inductively Coupled Plasma (ICP)



# Inductively Coupled Plasma (ICP)

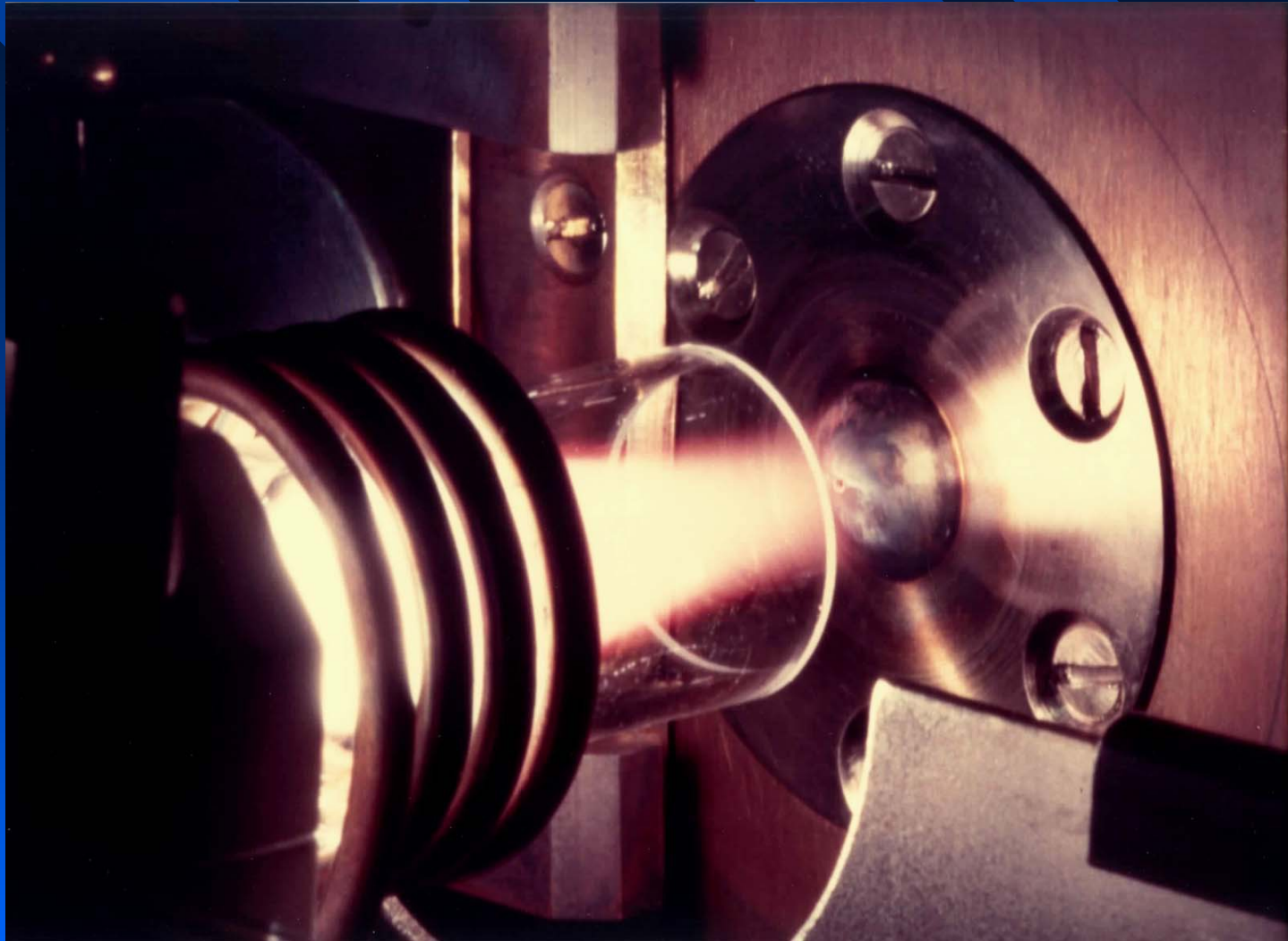
$h\nu$



Mass  
Spectrometer



# Inductively Coupled Plasma - Mass Spectrometry

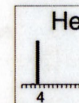
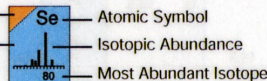




# Amplifying Ultratrace Analysis

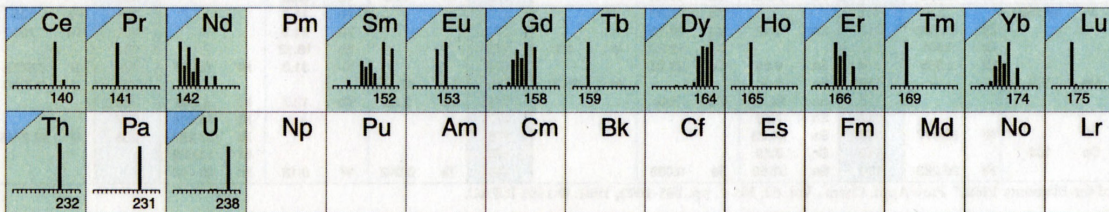
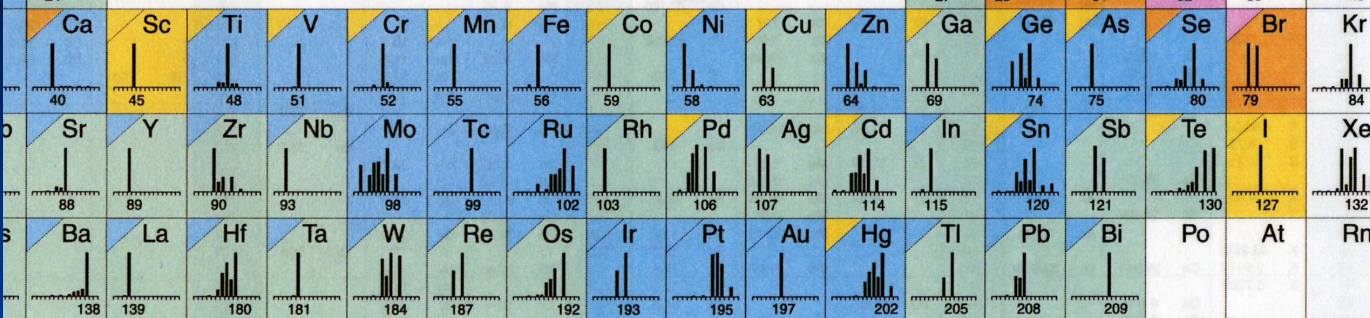
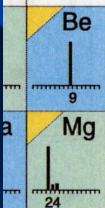
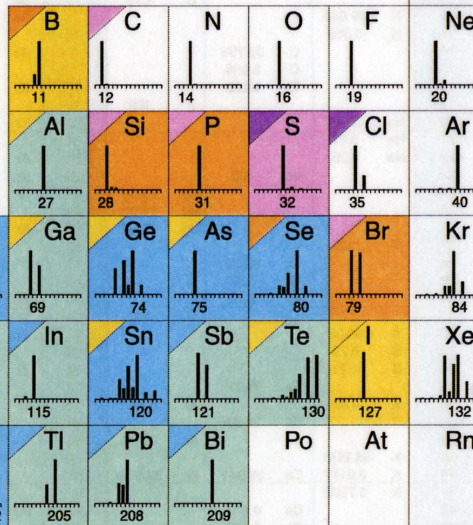


ELAN 9000 Detection Limit  
 ELAN DRC II Detection Limit  
 (in Class 100 clean room)



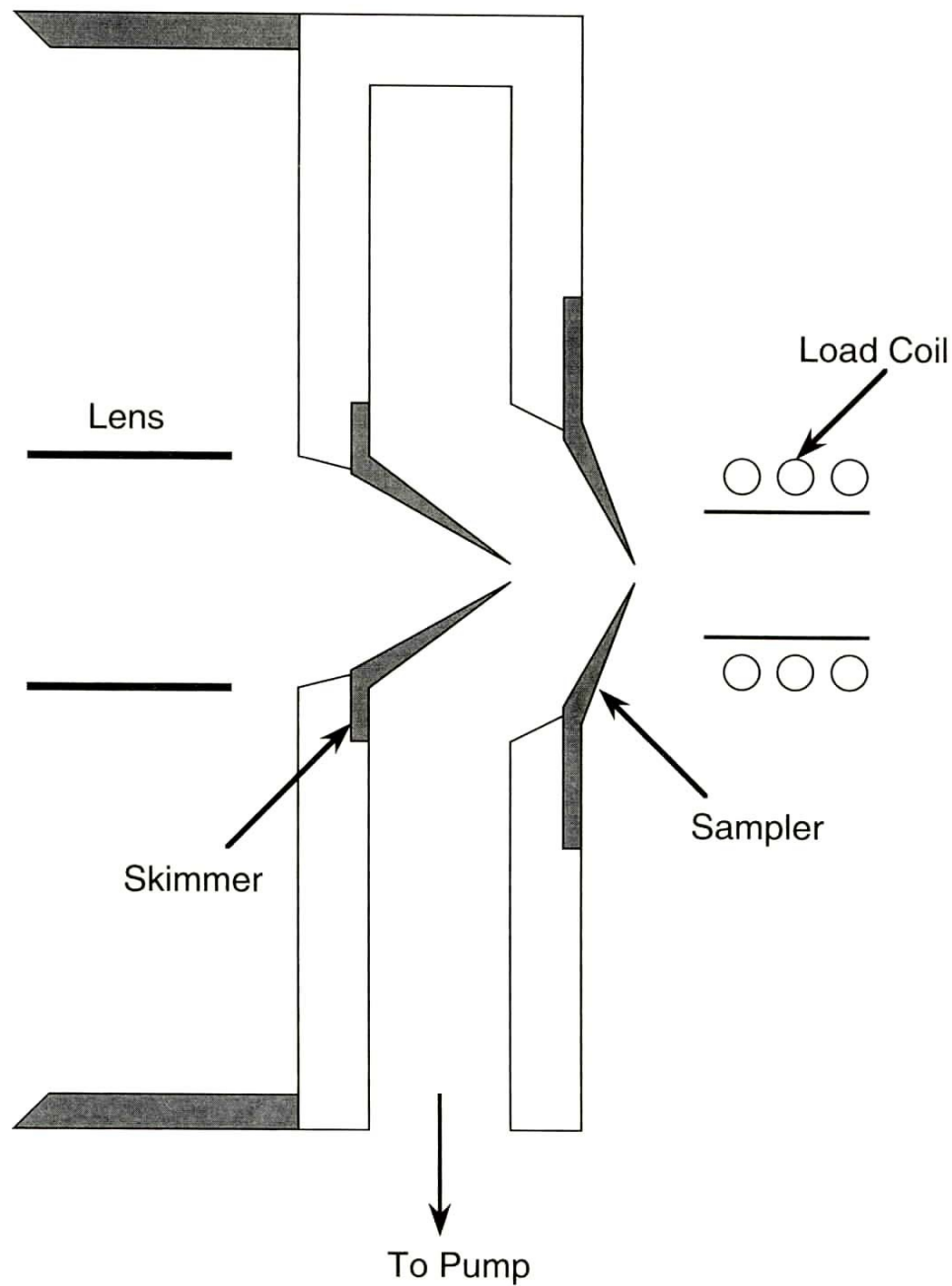
### Detection Limit Ranges

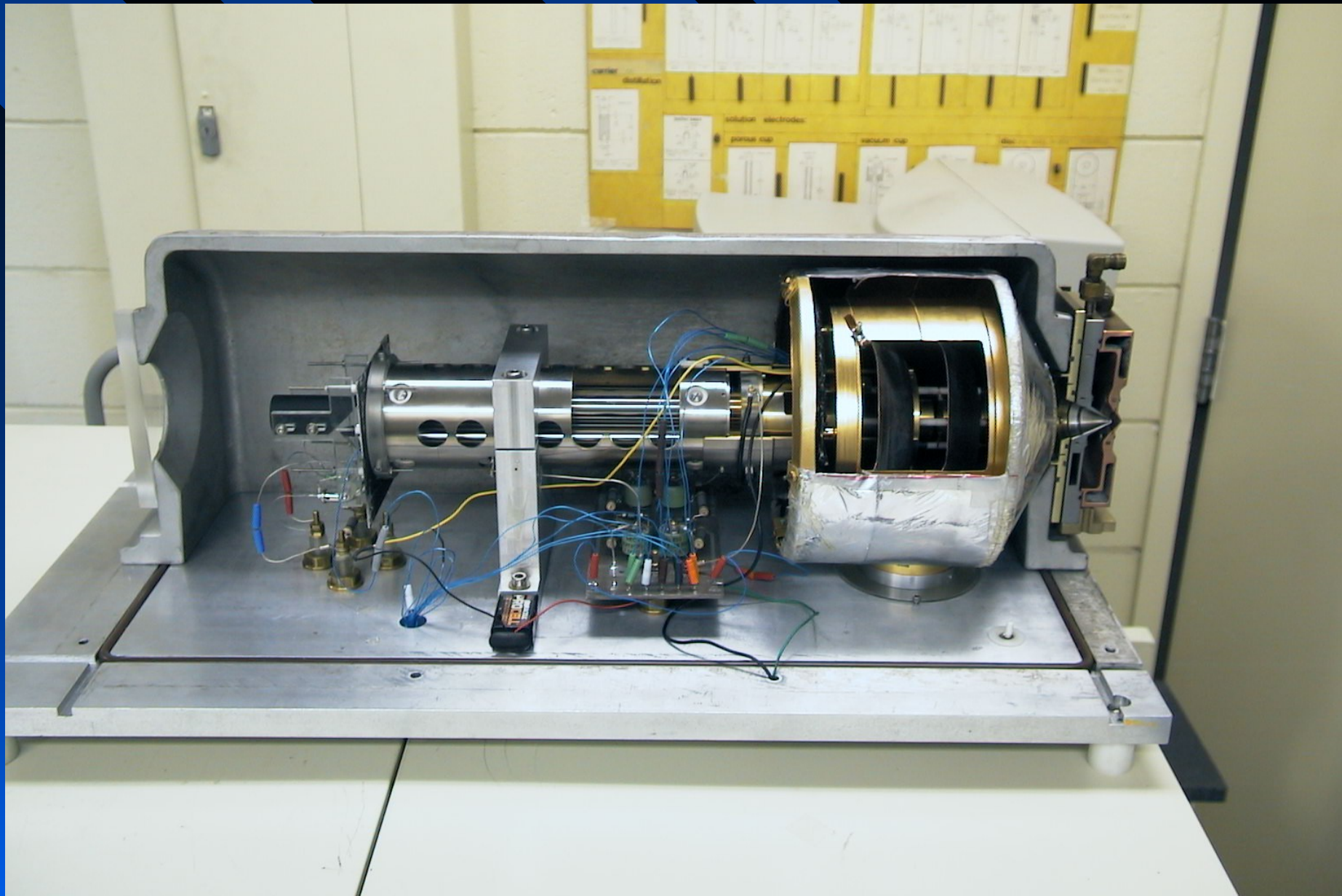
- < 0.1 ppt
- 0.1-1 ppt
- 1-10 ppt
- 10-100 ppt
- 0.1-1 ppb
- 1-10 ppb

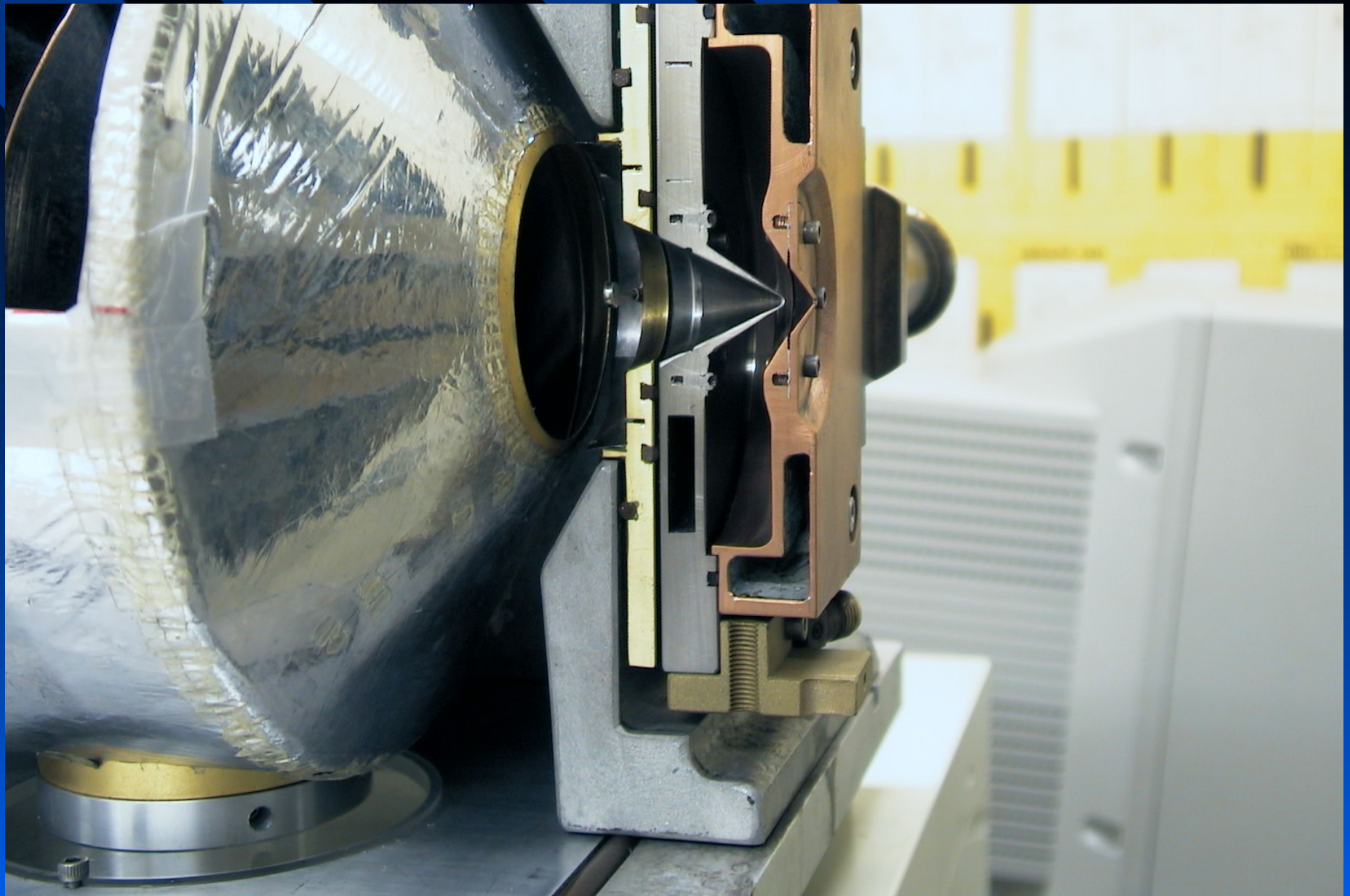


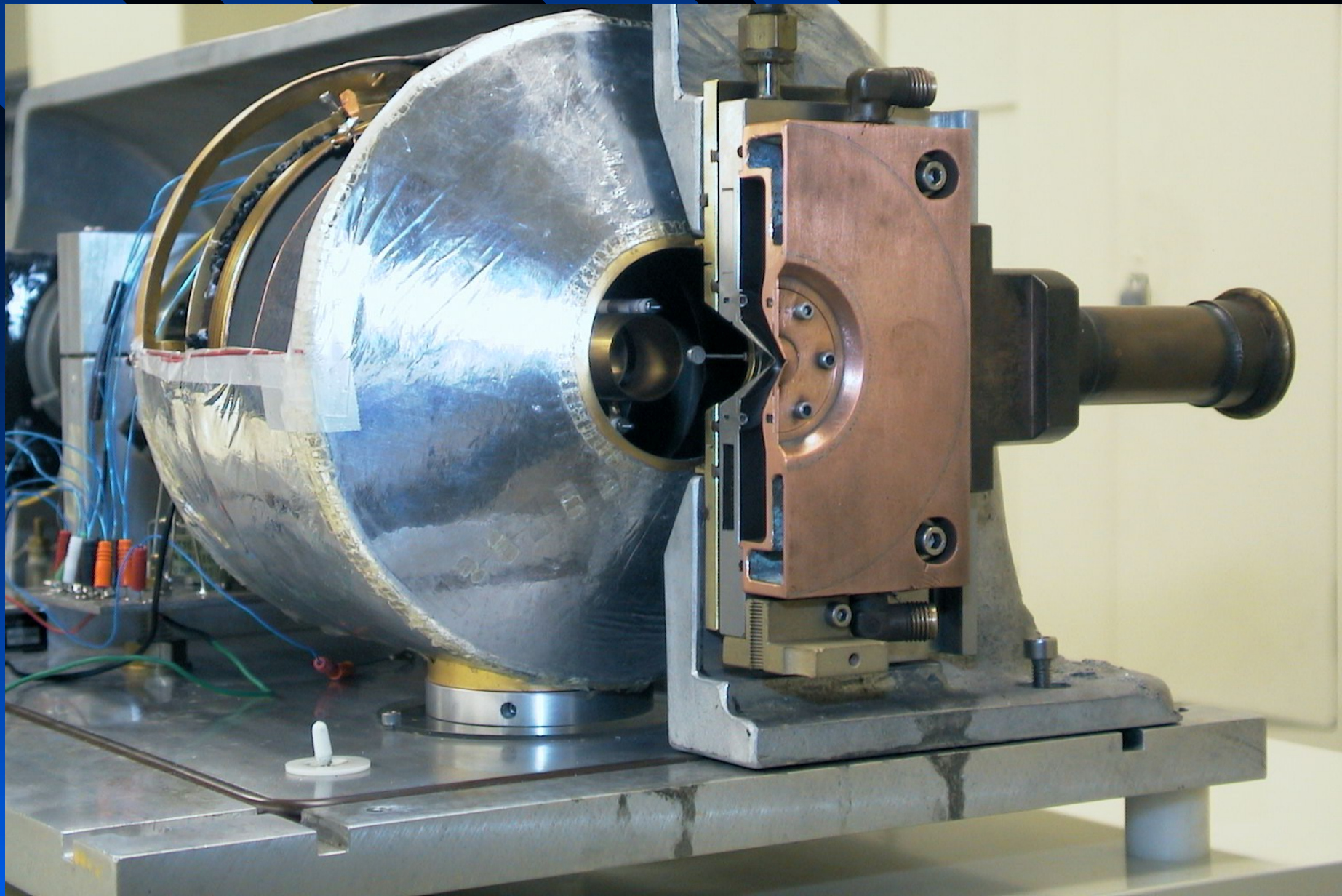
DRC-e performance typically between DRC II and ELAN 9000

# ICP-MS Interface Cones

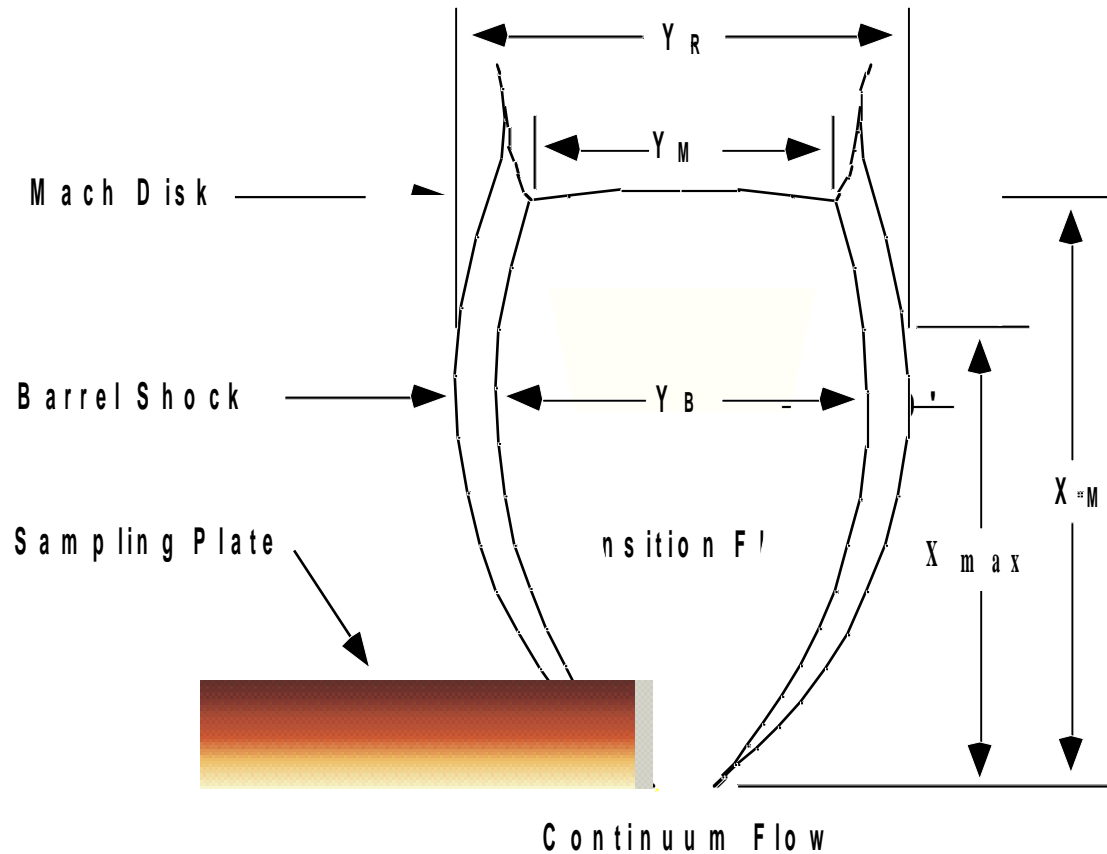








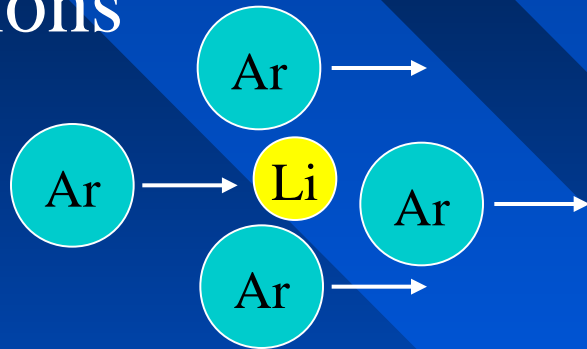
# Supersonic Expansion



# Consequences of Expansion

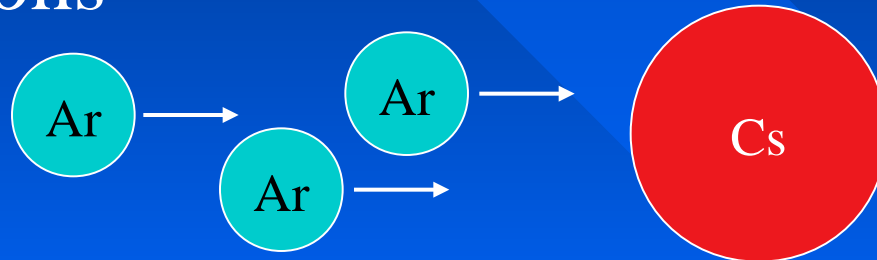
$$KE_{Ar} = \frac{5}{2} kT$$

Small ions

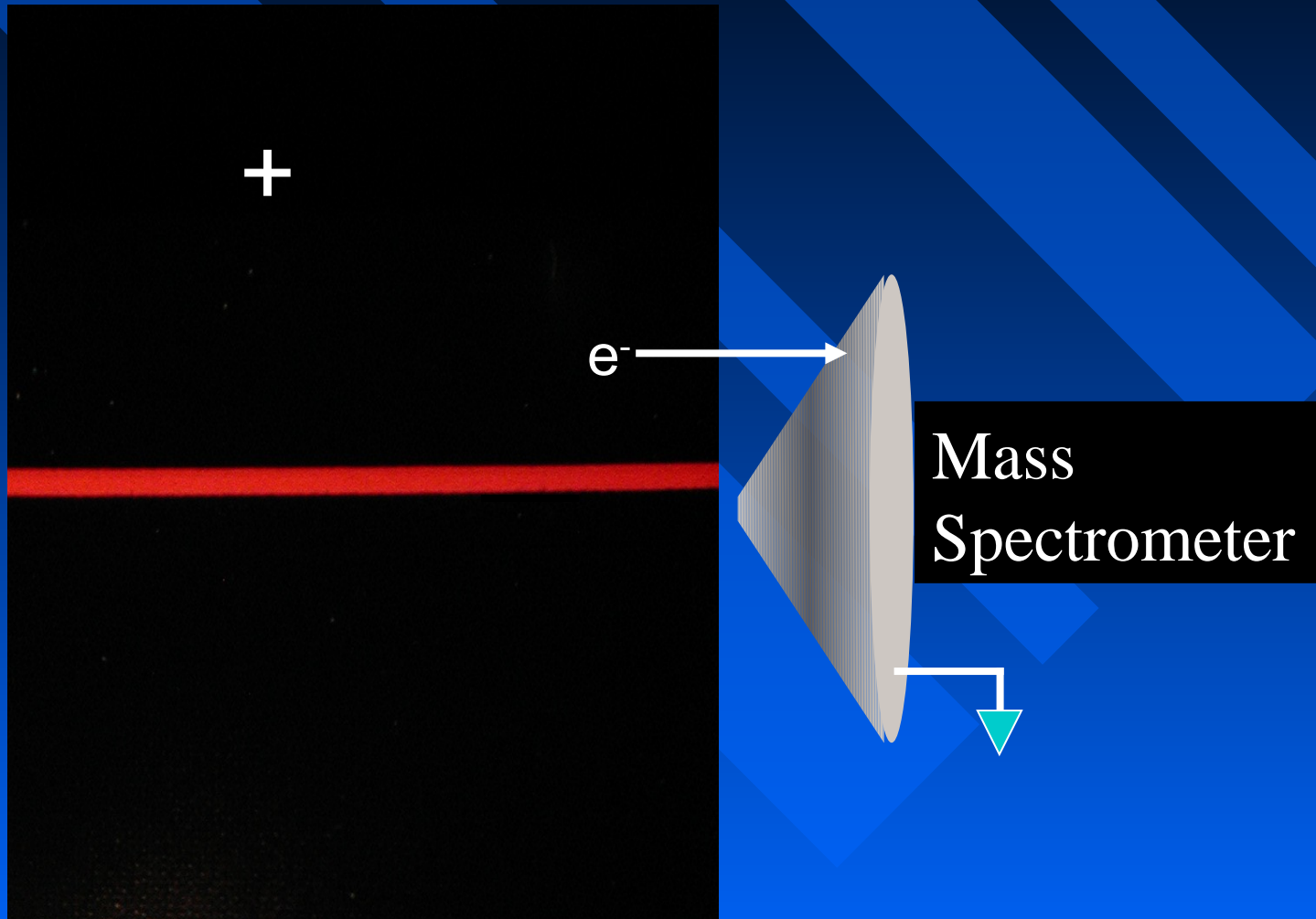


$$KE = 0.5 \text{ MV}^2$$
$$\text{So } KE_{M^+} = kM^+$$

Large ions

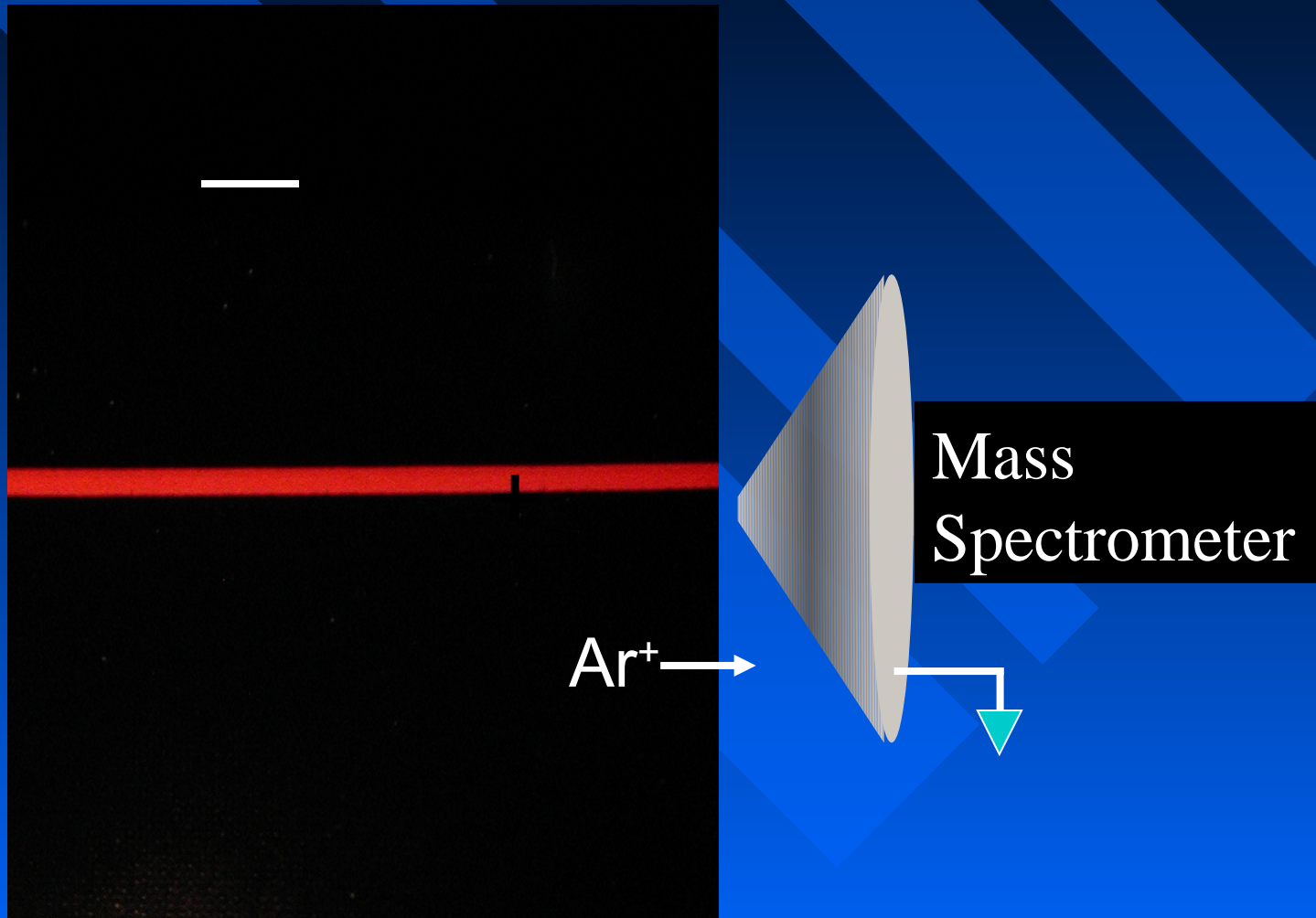


# Plasma Offset (Rectification)

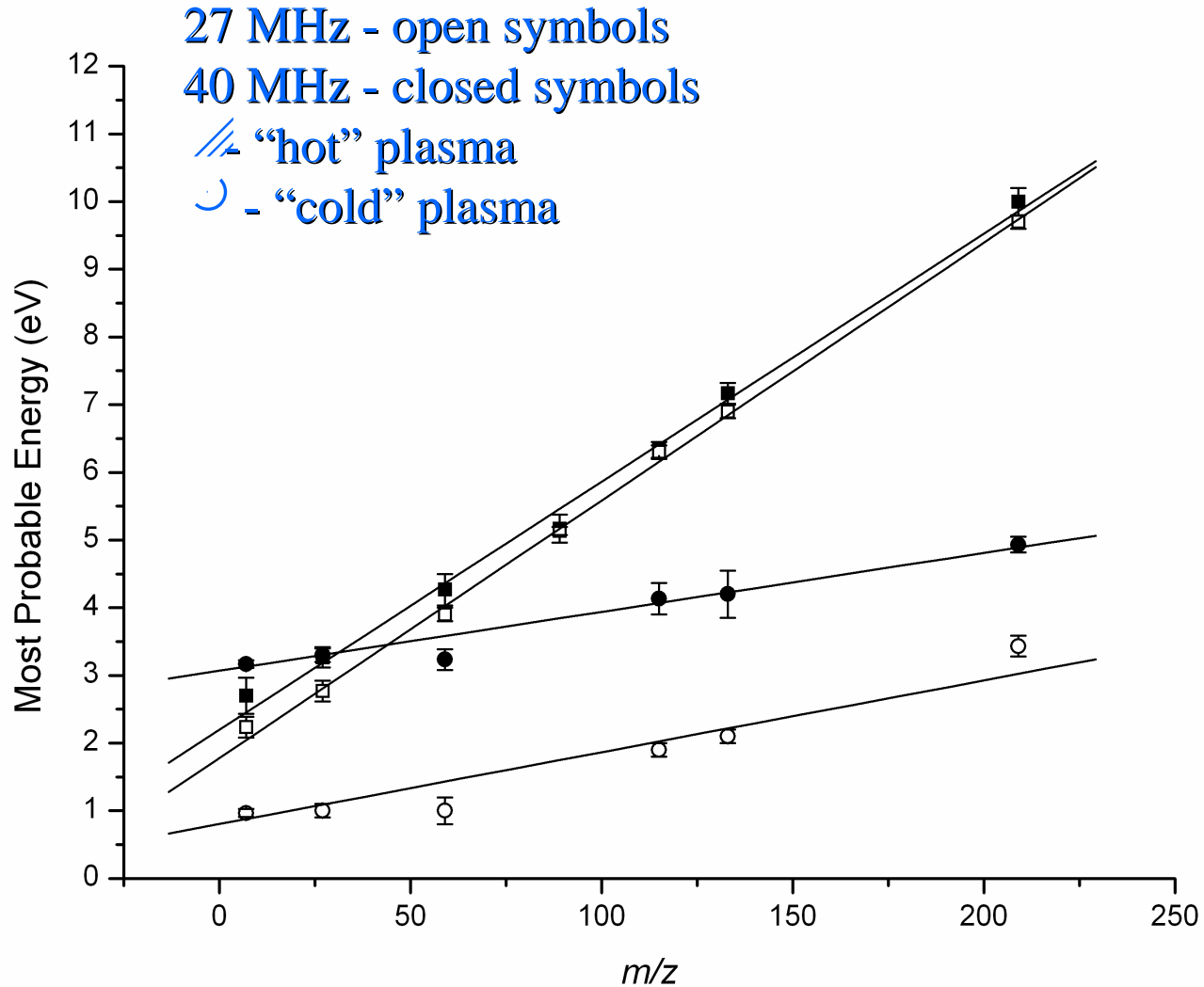




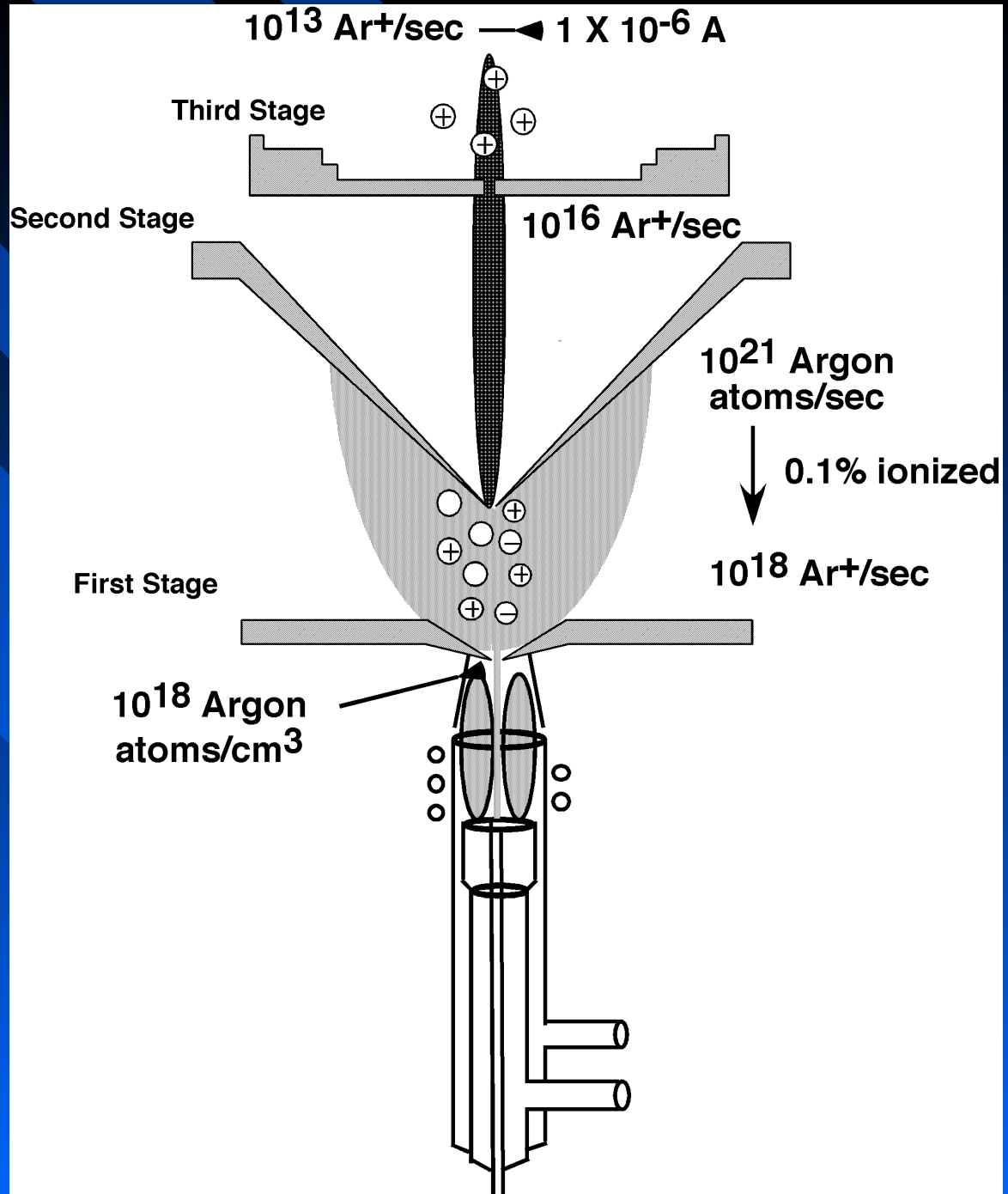
# Plasma Offset (Rectification)



# Ion Energies Depend on Mass



# Ion Currents in ICP-MS



# Spectral Characteristics of ICP-MS

## ■ Basic Background Species

- argon, water, and air.
- $N_2^+$ ,  $Ar^+$ ,  $ArO^+$ ,  $Ar_2^+$

## ■ Interelement Spectral Overlaps

- isobaric overlaps.
- element oxides and hydroxides.

## ■ Matrix Induced Spectral Overlaps

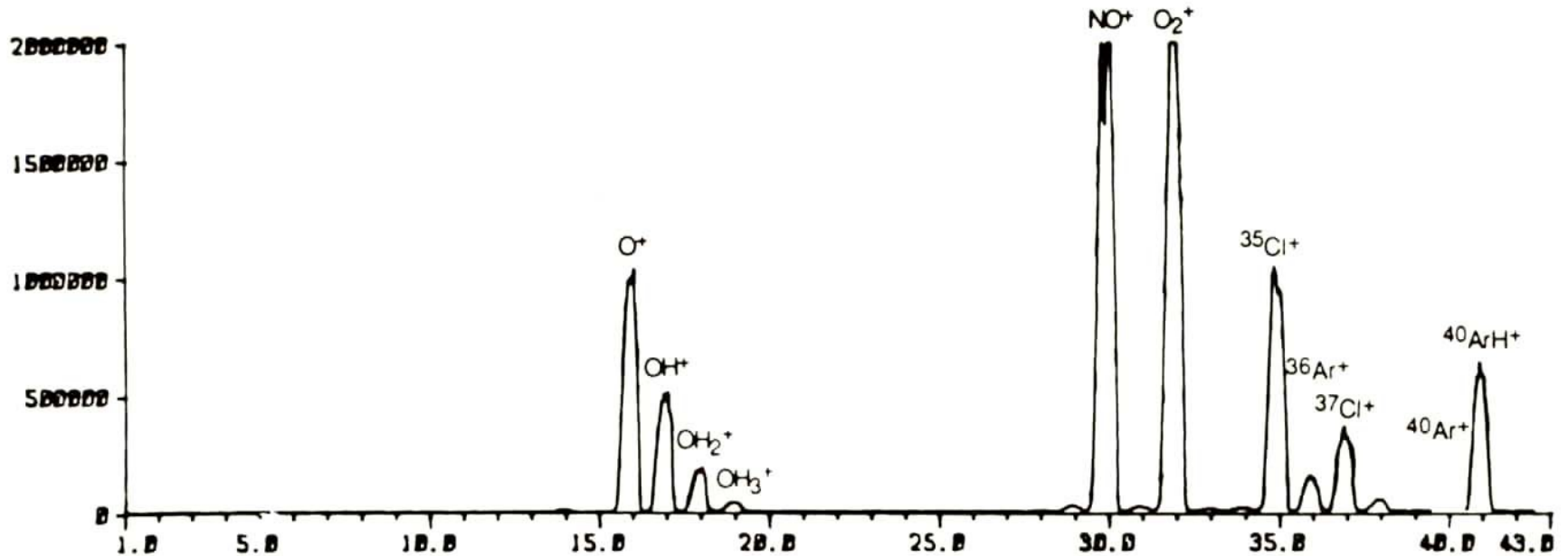
- chlorine and sulfur based species.
- $ClO^+$ ,  $SO_2^+$

## ■ Argon - Matrix Related Species

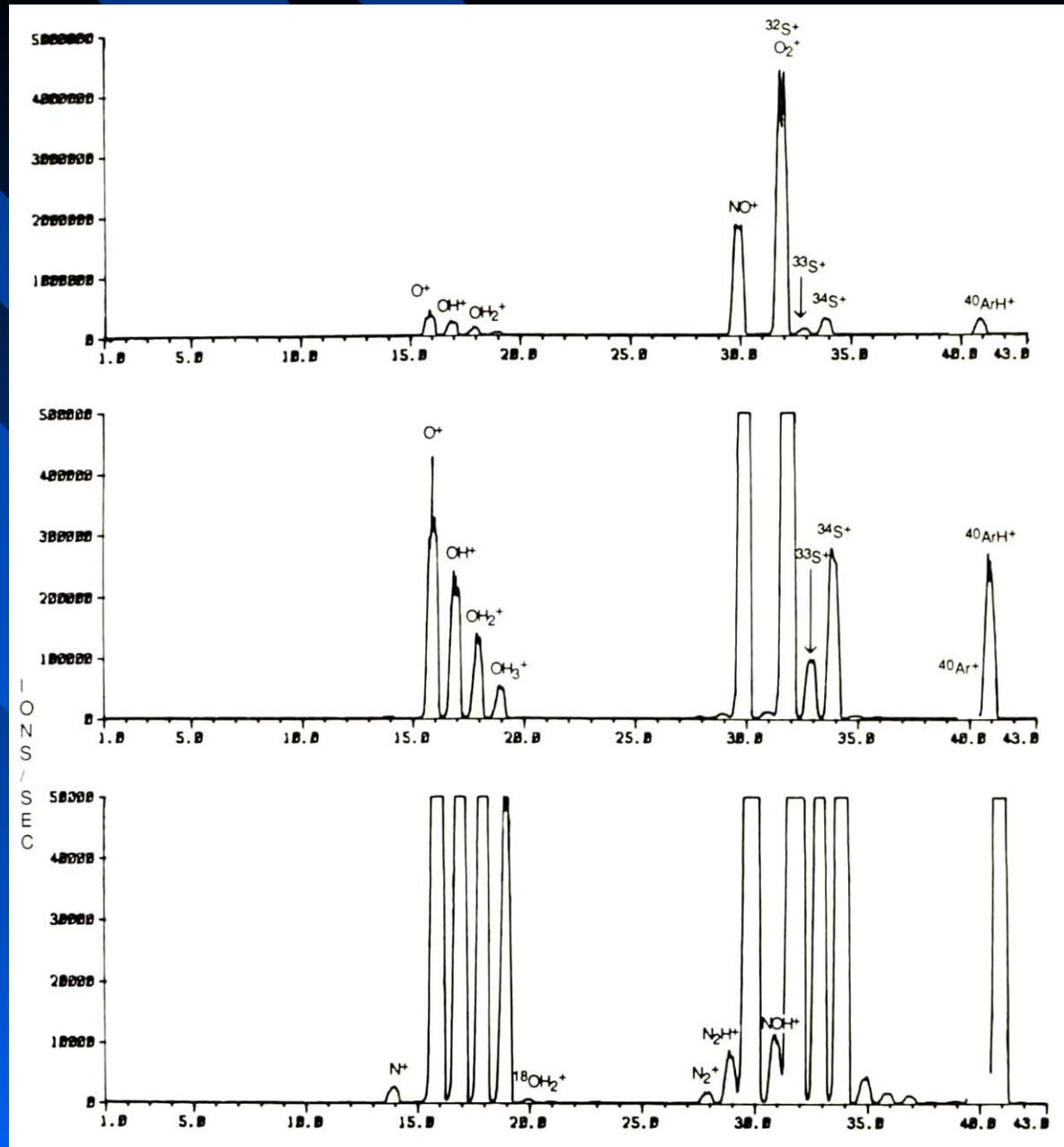
- $ArNa^+$ ,  $ArCl^+$

# ICP-MS Background: 5% HCl

Background Spectra for 5 % Hydrochloric Acid



# ICP-MS Background: 5% H<sub>2</sub>SO<sub>4</sub>



# Oxide and Hydroxide Species

## ■ Problems Caused by Oxides

- spectral interferences.
- can result in the implementation of inappropriate isobaric corrections.

## ■ Oxides Formed From

- plasma gases.
- air entrainment.
- sample solvent.
- matrix components of the sample.
- the sought-for-elements in the sample.

# Variables Affecting Oxide Levels

## ■ Oxide Levels Depend On:

- injector gas flow rate.
- forward power.
- sampler - skimmer spacing.
- sampler orifice size.
- plasma gas composition.
- aerosol processing.
- solvent load.
- oxygen level.

All these experimental variables can be used, to some extent, to control oxide levels in ICP-MS.

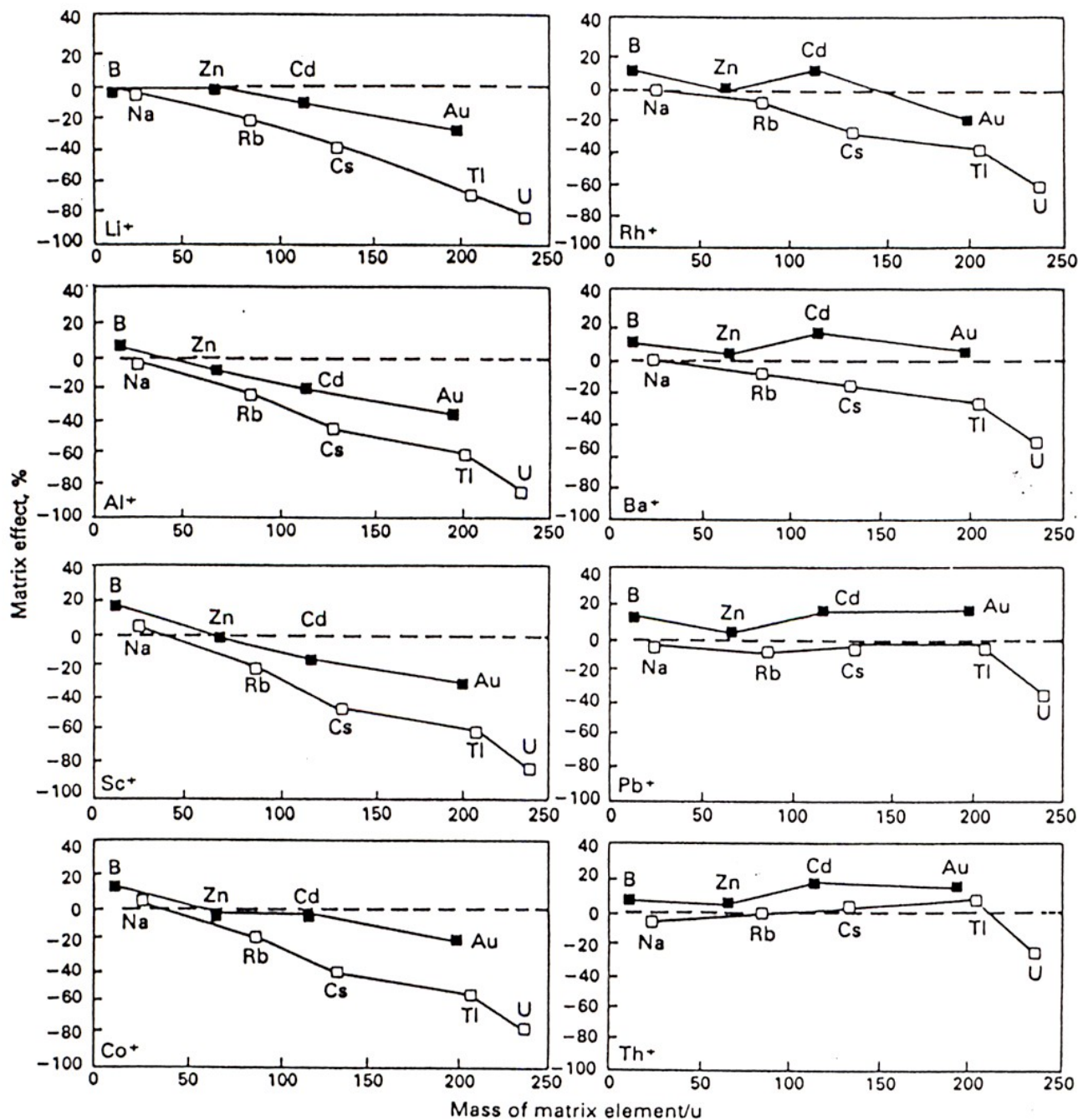


# Matrix Induced Signal Changes

**A high concentration of a concomitant:**

- generally, suppression of the analyte signal is observed.
- the suppression is more serious with heavier matrix elements.
- light analytes are more seriously affected.
- the effects may be minimized by:
  - reducing the nebulizer flow rate.
  - using an internal standard.
  - using dilute solutions.

# Matrix Effects in ICP-MS



# ICP-MS Options for Isotope Ratios

- Multi-collector sector-field spectrometer
  - Offered by Thermo (Neptune), GV, and Nu
  - Isotope-ratio precision  $\sim 0.002\%$  rsd (20 ppm)
- Time-of-flight mass spectrometer
  - Leco & GBC
  - Isotope-ratio precision  $\sim 0.05\%$  rsd analog
  - Isotope-ratio precision  $\sim 0.01\%$  rsd counting
- Array-detector sector field
  - Not yet commercially available
  - Isotope-ratio precision  $\sim 0.007\%$  rsd

# Thermo Neptune MC-ICP-MS



# Nu Instruments MC-ICP-MS



# Leco Renaissance ICP-TOFMS



# GBC Optimass ICP-TOFMS

